

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Confirmation No. 5700

In re Patent Application of

New York, New York

Katsuhiko MIYA et al.

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Group Art Unit: 1792

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For: SUBSTRATE PROCESSING APPARATUS

VIA EFS-WEB

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of Japanese reference together with a form listing the same for the convenience of the Examiner. This reference was erroneously listed as "2002-282784" on the PTO Form-1449 submitted with the Information Disclosure Statement on November 19, 2008. The reference should have been listed as "2002-282764". The revised PTO Form-1449 reflects this change.

I certify that each item of information contained in this Submission was cited in a communication from a foreign patent office in a counterpart foreign application not more than 3 months prior to the filing of this Submission. I certify that each item of information contained in this Submission was cited in a communication from a foreign patent office in a counterpart foreign application not more than 3 months prior to the filing of this Submission.

No fee is believed to be due with this submission, since it is being made prior to issuance of a first Office Action concerning this matter. If any fee is due, however, authorization is hereby provided to charge the required amount to Deposit Account No. 15-0700.

Respectfully submitted,

THIS CORRESPONDENCE IS BEING
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ON December 16, 2008



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